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Name: Stephen Rosasco, Primary Examiner
Company: U.S. Patent and Trademark Office
Fax Number: 571-273-8300
Phone Number: 571-272-1389
Date: May 3, 2006
Subject: US Application No. 10/668,245
Inventor: Kyoko Izuha et al.
Filed: September 24, 2003

FROM

Name: David L. Soltz
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Fax Number Verified by: A. Pinkney 1018
Total Pages (including cover): -10-
Attny. Docket 04329.3147

Confirmation Copy to Follow: No

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COURTESY COPY OF AMENDMENT AFTER ALLOWANCE

FILED MAY 3, 2006

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PATENT
Attorney Docket No. 04329.3147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1756
)
Kyoko Izuha et al.)
) Examiner: Rosasco, Stephen D.
Application No.: 10/668,245)
) Notice of Allowance Dated: March 28, 2006
Filed: September 24, 2003)
) Mail Stop Issue Fee
For: MASK, MANUFACTURING)
METHOD FOR MASK, AND) Confirmation No.: 2059
MANUFACTURING METHOD)
FOR SEMICONDUCTOR)
DEVICE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER ALLOWANCE

Pursuant to 37 C.F.R. § 1.312 and subject to the recommendation of the Examiner and the approval of the Director, and without withdrawing the case from issue, kindly amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.